



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 3781**
Eiichi ISHII et al. : Docket No. 2003_1290
Serial No. 10/659,327 : Group Art Unit 1742
Filed September 11, 2003 :
METHOD OF SURFACE TREATMENT :
OF TITANIUM METAL :

RE: INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In connection with the IDS filed September 11, 2003, please note that an English language abstract of JP 07-090542 cited in the IDS is of record in the now abandoned parent application, Serial No. 09/902,260. The English language abstract was submitted with the IDS of December 31, 2001 in the parent application.

Respectfully submitted,

Eiichi ISHII et al.

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

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December 18, 2003